

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 89518
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Mou-Shiung Lin et al.	:	Confirmation Number: 6138
	:	
Application No.: 09/523,990	:	Group Art Unit: 2887
	:	
Filed: March 13, 2000	:	Examiner: Daniel I. Walsh
	:	
For: METHOD OF MANUFACTURE AND IDENTIFICATION OF SEMICONDUCTOR CHIP MARKED FOR IDENTIFICATION WITH INTERNAL MARKING INDICIA AND PROTECTION THEREOF BY NON-BLACK LAYER AND DEVICE PRODUCED THEREBY		

CHANGE TO LARGE ENTITY STATUS

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF ELECTRONIC TRANSMISSION

I hereby certify that this correspondence is being electronically-transmitted to
the United States Patent and Trademark Office on **April 9, 2010**.
/Tobi A. Herbert/

Tobi A. Herbert

Sir:

This communication hereby notifies the United States Patent and Trademark Office of a change in status of the above-identified application from small entity to large entity. Any fees due in the above-identified application will be paid as large entity to reflect this change.

Respectfully submitted,
McDERMOTT WILL & EMERY LLP

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